

Title (en)

Coating compositions for use with an overcoated photoresist

Title (de)

Beschichtzungszusammensetzungen zur Benutzung in einem beschichteten Photoresist

Title (fr)

Compositions de revêtement pour utilisation dans une photoréserve revêtue

Publication

EP 1598702 A1 20051123 (EN)

Application

EP 05253017 A 20050517

Priority

US 57201304 P 20040518

Abstract (en)

Compositions (particularly antireflective coating compositions or "ARCs") are provided that can reduce reflection of exposing radiation from a substrate back into an overcoated photoresist layer and/or function as a planarizing or via-fill layer. More particularly, the invention relates to organic coating compositions, particularly antireflective coating compositions, that contain a polyester resin component that contains repeat units that comprise phenolic and/or hydroxyalkylcyanurate groups.

IPC 1-7

G03F 7/09

IPC 8 full level

G03F 7/11 (2006.01); **C08G 63/60** (2006.01); **C08G 63/685** (2006.01); **G03F 7/09** (2006.01); **H01L 21/027** (2006.01)

CPC (source: EP KR US)

G03F 7/091 (2013.01 - EP KR US); **G03F 7/11** (2013.01 - KR)

Citation (search report)

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Designated contracting state (EPC)

DE FR GB

DOCDB simple family (publication)

EP 1598702 A1 20051123; CN 100503756 C 20090624; CN 1704455 A 20051207; JP 2005346051 A 20051215; JP 4738054 B2 20110803; KR 20060048011 A 20060518; TW 200613919 A 20060501; US 2006057491 A1 20060316

DOCDB simple family (application)

EP 05253017 A 20050517; CN 200510087808 A 20050517; JP 2005143862 A 20050517; KR 20050041800 A 20050518; TW 94116038 A 20050518; US 13190805 A 20050517